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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Allen et al  
U.S. Serial No. : 09/931,339  
Filing Date : August 16, 2001  
For : RADIATION-CURABLE SILICONE ELASTOMERS  
Group Art Unit : N/A

745 Fifth Avenue  
New York, New York 10151

I hereby certify that this correspondence is being  
deposited with the United States Postal Service as  
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Commissioner of Patents and Trademarks,  
Washington, D.C. 20231, on January 25, 2001

William F. Lawrence, Registration No. 28,029

Name of Applicant, Assignee or  
Registered Representative

[Signature]  
Signature

January 25, 2001  
Date of Signature

INFORMATION DISCLOSURE STATEMENT

RECEIVED  
FEB-5 2002  
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Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Enclosed are copies of publications the subject matters  
of which are mentioned in the specification for the Examiner's  
review:

1. US 4,587,159, May 6, 1986, Gutek et al;
2. US 5,004,643, April 2, 1991, Caldwell;

3. US 5,209,965, May 11, 1993, Caldwell;
4. US 5,418,051, May 23, 1995, Caldwell;
5. US 4,666,765, May 19, 1987, Caldwell et al;
6. US 4,978,726, December 18, 1990, Döhler et al;
7. US 5,494,945, February 27, 1996, Kidon et al;
8. US 5,391,405, February 21, 1995, Irifune et al;
9. US 5,494,979, February 27, 1996, Ebbrecht et al;
10. US 5,863,966, January 26, 1999, Ebbrecht et al;
11. US 4,675,346, June 23, 1987, Lin et al;
12. US 4,929,647, May 29, 1990, Burger et al;
13. US 4,963,438, October 16, 1990, Weitemeyer et al;
14. US 4,940,766, July 10, 1990, Gay et al;
15. US 4,575,546, March 11, 1986, Klemarczyk et al;
16. US 4,575,545, March 11, 1986, Nakos et al;
17. US 5,091,483, February 25, 1992, Mazurek et al;
18. US 6,211,322, April 3, 2001, Döhler et al;
19. US 5,552,506, September 3, 1996, Ebbrecht et al;
20. US 4,271,425, June 2, 1981, Wong.

We have enclosed a copy of PTO-1449 in duplicate which is considered part of the Information Disclosure Statement.

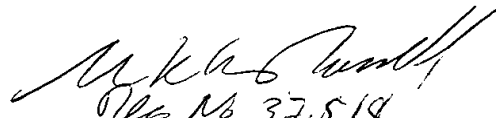

This Information Disclosure Statement is being submitted prior to receipt of a first Office Action, so no fee is deemed

necessary. However, if a fee is required, the Examiner is hereby authorized to charge our Deposit Account 50-0320.

Applicant respectfully requests that the Examiner consider and make of record the documents cited herein and that a copy of Form PTO-1449 be initialed by the Examiner and returned to the undersigned.

Respectfully submitted,

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